



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

OHTAKE, Fumio et al.

Group Art Unit: **2814**

Serial No.: **09/749,590**

Examiner: **MAI, Anh D.**

Filed: **December 28, 2000**

P.T.O. Confirmation No.: **4831**

For: **SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME**

REQUEST FOR APPROVAL OF DRAWING CHANGES

Commissioner for Patents
Washington, D.C. 20231

October 2, 2002

*Approved
A.M.
12/10/02*
The Examiner's approval of the drawing corrections indicated in red ink on the attached 6 sheets of drawings is respectfully requested.

Upon receipt of approval of the drawing corrections and a formal Notice of Allowance, a bonded draftsman will be retained and the appropriate corrections will be made.

In the event any fees are required in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

Sadao Kinashi

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SK/fs

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PATENT TRADEMARK OFFICE

Attachment: 6 Sheets of Corrected Drawings (Figs. 5, 6, 7, 8, 9 and 11)

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